

<b>Notice of References Cited</b>	Application/Control No. 10/799,307		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner LUCY P. CHIEN		Art Unit 2871	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,922,219	07-2005	Jin et al.	349/113
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	K	US-			
	L	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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